

CLAIM AMENDMENTS

1 1. (currently amended) A diode-pumped laser apparatus
2 for generating a visible power beam, ~~of the type~~ the laser
3 apparatus comprising:

4 a linear miniaturized laser cavity ~~(72)~~ having crystals
5 and a length that does not exceed the sum of ten times the sum of
6 the lengths of the crystals; comprising at least the following
7 optical elements (30,33,36,10,20):

8 ~~reflecting means~~ a plurality of reflectors (30,33,36)
9 that are highly reflective at a fundamental wavelength of a laser
10 beam ~~[(52)]~~ generated by ~~said cavities~~ the laser cavity [(72)],
11 at least one of said ~~reflecting means~~ reflectors [(30)] being
12 traversed by a pumping beam, ~~(54)~~, ~~at least one of said reflecting~~
13 ~~means (36) being~~ and reflecting at said fundamental wavelength and
14 a second harmonic wavelength ~~[(51)]~~ with respect to said
15 fundamental wavelength, ~~and at least one of said reflecting means~~
16 ~~(33) being~~ highly transmissive at said second harmonic ~~[(51)]~~ of
17 said fundamental wavelength; ~~[-]~~

18 an active material ~~[(10)]~~ with linear polarized
19 emission and with a gain configuration with small thermal
20 aberration for ~~[[the]]~~ cavity mode, said active material ~~[(10)]~~
21 being able to generate said laser beam ~~[(52)]~~ at ~~[[a]]~~ the
22 fundamental wavelength; ~~[-]~~

23 a nonlinear crystal ~~[[(20) ,]]~~ inside said cavity ~~(72) ,~~
24 ~~characterized in that: said nonlinear crystal (20) is~~ and able to
25 generate a second harmonic ~~[[(51)]]~~ of said fundamental wavelength
26 by critical type I phase matching; ~~and that said cavity (72) is~~
27 ~~associated to~~

28 thermostating means associated with the cavity
29 ~~(45,41,42,43,44)~~ for temperature locking said cavity, the
30 reflectors, the active material, and the nonlinear crystal ~~(72) and~~
31 ~~its optical elements (30,33,36,10,20).~~

1 2. (currently amended) The ~~[[an]]~~ apparatus ~~[[as]]~~
2 claimed in claim 1 ~~, characterized in that wherein~~ said cavity
3 ~~[[(72)]]~~ and the optical ~~means (30,33,36,10,20) which~~ elements it
4 comprises are ~~selected~~ provided to ~~minimis~~ minimize optical
5 losses.

1 3. (currently amended) ~~[[An]]~~ The apparatus ~~[[as]]~~
2 claimed in claim 1 ~~, characterized in that said wherein~~ optical
3 losses at said fundamental wavelength are less than 2%.

1 4. (currently amended) The ~~[[An]]~~ apparatus ~~[[as]]~~
2 claimed in claim 1 ~~, characterized in that said wherein~~ optical
3 losses at said fundamental wavelength due to thermal aberration are
4 less than 1%.

1 5. (currently amended) The [[An]] apparatus [[as]]
2 claimed in claim 1 ~~, characterized in that~~ wherein the active
3 material [[(10)]] is a crystal of Nd:GdVO₄.

1 6. (currently amended) The [[An]] apparatus [[as]]
2 claimed in claim 1 ~~, characterized in that~~ wherein the active
3 material [[(10)]] is a crystal of Nd:YLF.

1 7. (currently amended) The [[An]] apparatus [[as]]
2 claimed in claim 1 ~~, characterized in that~~ wherein the active
3 material [[(10)]] is a crystal of Nd:YVO₄.

1 8. (currently amended) The [[An]] apparatus [[as]]
2 claimed in claim 5 ~~, characterized in that~~ wherein the nonlinear
3 crystal is LBO.

1 9. (currently amended) The [[An]] apparatus [[as]]
2 claimed in claim 5 ~~, characterized in that~~ wherein the nonlinear
3 crystal is YCOB or GdCOB.

1 10. (currently amended) The [[An]] apparatus [[as]]
2 claimed in claim 1 ~~, characterized in that~~ wherein said visible
3 beam ~~(51) is a beam~~ is at the limit of diffraction [[,]] or TEM_{0,0}.

1 11. (currently amended) The ~~[[An]]~~ apparatus ~~[[as]]~~
2 claimed in claim 1 ~~, characterized in that~~ wherein the pumping beam
3 ~~[[54]]~~ is absorbed in two successive passes through the active
4 material ~~[(10)]~~.

1 12. (currently amended) The apparatus ~~[[as]]~~ claimed in
2 claim 1 ~~, characterized in that~~ wherein said thermostating means
3 ~~(45;41;42;43;44)~~ for temperature locking said cavity, the
4 reflector, the active material, and the nonlinear crystal ~~(72) and~~
5 ~~its optical elements~~ comprise a mechanical structure
6 ~~(45;41;42;43;44)~~ associated ~~[[to]]~~ with said cavity ~~[(72)]~~.

1 13. (currently amended) The apparatus ~~[[as]]~~ claimed in
2 claim 12 ~~, characterized in that~~ wherein said mechanical structure
3 comprise a structural base ~~[(45),]~~ and elements for supporting
4 the optics ~~(41;42;43;44)~~.

1 14. (currently amended) The apparatus ~~[[as]]~~ claimed in
2 claim 12 ~~, characterized in that~~ wherein said structural base
3 ~~[(45)]~~ and elements supporting the optics ~~(41;42;43;44)~~ are made
4 of copper or other heat conducting material and ~~associated~~ are in
5 thermal contact with each other.

1 15. (currently amended) The [[An]] apparatus [[as]]
2 claimed in claim 12 ~~, characterized in that~~ wherein the temperature
3 of the structural base [[(45)]] is regulated by means of an active
4 system.

1 16. (currently amended) The [[An]] apparatus [[as]]
2 claimed in claim 12 wherein ~~characterized in that~~ said mechanical
3 structure ~~(45;41;42;43;44)~~ has the shape of a container, containing
4 said cavity [[(72)]] in sealed way.

1 17. (currently amended) The apparatus [[as]] claimed in
2 claim 1 ~~, characterized in that~~ wherein said thermostating means
3 ~~(45;41;42;43;44)~~ comprise an additional autonomous heat-regulating
4 device to stabilize the temperature of the nonlinear crystal
5 [[(20)]] in autonomous and more precise way than the other elements
6 of the cavity.

1 18. (currently amended) The apparatus [[as]] claimed in
2 claim 1 ~~, characterized in that~~ wherein the reflecting means
3 reflectors ~~(30;33;36)~~ are at least in part obtained ~~by means of~~
4 formed by reflecting depositions on the laser crystal [[(10)]]
5 ~~[[and/]]~~ or on the nonlinear crystal [[(20)]].

6 19. (currently amended) A method for generating a
7 visible laser beam in a laser cavity [(72)] of the type whereby a
8 nonlinear crystal [(20)] is inserted into said laser cavity
9 [(72)] to obtain said visible laser beam [(51)] through a
10 second harmonic generation operation, ~~characterized in that it~~
11 ~~comprises the following operations~~ the method comprising the steps
12 of: [-]

13 selecting a nonlinear crystal [(20)] cut for critical
14 type I phase matching; [-]

15 aligning said nonlinear crystal [(20)] at a temperature
16 predetermined by [(the)] a thermostating means [(45)] associated
17 [(to)] with said cavity [(72)] obtaining the phase matching
18 condition; [-]

19 optimizing the conversion into second harmonic with
20 additional small temperature adjustments around the predetermined
21 value.

1 20. (currently amended) The method [(as)] claimed in
2 claim 19 , ~~characterized in that~~ wherein the temperature regulation
3 operation occurs in negative feedback, detecting [(the)] an actual-
4 value signal of a sensor positioned in proximity to the nonlinear
5 crystal.

1 21. (currently amended) The ~~[[A]]~~ method ~~[[as]]~~ claimed
2 in claim 19, ~~characterized in that it further comprises the~~
3 ~~operations~~ further comprising the steps of: ~~[[-]]~~

4 reducing ~~[[the]]~~ walk-off of the fundamental laser beam
5 ~~[[(52)]]~~ operating on the dimension of the cavity mode inside the
6 nonlinear crystal ~~[[(20)]]~~, in order to contain ~~[[the]]~~ a walk-off
7 angle inside the divergence of the beam; ~~[[-]]~~

8 selecting the length of the nonlinear crystal as a
9 function of the desired focusing.

1 22. (new) The apparatus according to claim 1 wherein
2 the active material is arranged to keep the aberration losses at
3 less than 2%.